

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q93188

Takashi YAMADA, et al.

Appln. No.: 10/568,087

Group Art Unit: 2882

Confirmation No.: 7478

Examiner: Chih Cheng G KAO

Filed: February 13, 2006

For: EUV LIGHT SOURCE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 13, 2008, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE SPECIFICATION .....	2
AMENDMENTS TO THE CLAIMS .....	3
REMARKS .....	5